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1763

**PATENT APPLICATION****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: 005651 USA/ETCH/CHMBR/JB1

Michael BARNES, et al.

Appln. No.: 09/834,343

Group Art Unit: 1763

Confirmation No.: 2414

Examiner: A. Crowell

Filed: April 12, 2001

For: PLASMA REACTOR ELECTRODE

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TC 1700**INFORMATION DISCLOSURE STATEMENT  
UNDER 37 C.F.R. §§ 1.97 and 1.98**Commissioner for Patents  
P.O. Box 2327  
Arlington, VA 22202

Sir:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached PTO/SB/08 A & B (modified) form and which the Examiner may deem material to patentability of the claims of the above-identified application.

One copy of each of the listed documents is submitted herewith, along with a copy of the corresponding Communication from a Foreign Patent Office.

The present Information Disclosure Statement is being filed after the later of three months from the application's filing date and the mailing date of the first Office Action on the merits, but before a Final Office Action, Notice of Allowance, or an action that otherwise closes prosecution in the application (whichever is earlier), and therefore Applicant is filing

**INFORMATION DISCLOSURE STATEMENT**  
U.S. Appln. No.: 09/834,343

concurrently herewith a Statement Under 37 C.F.R. § 1.97(e). No fee under 37 C.F.R. § 1.17(p) is required.

The submission of the listed documents is not intended as an admission that any such document constitutes prior art against the claims of the present application. Applicant does not waive any right to take any action that would be appropriate to antedate or otherwise remove any listed document as a competent reference against the claims of the present application.

Respectfully submitted,

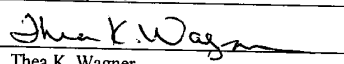


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Date: March 12, 2003

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Signed:	<u></u> Thea K. Wagner



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STATEMENT UNDER 37 C.F.R. § 1.97(e)

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TC-1700

Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of said Information Disclosure Statement.

Respectfully submitted,

Frank L. Bernstein  
Registration No. 31,484

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